



IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

CHEN, I-Cherng et al.

Conf.:

6047

Appl. No.:

10/690,503

Group:

1775

Filed:

October 23, 2003

Examiner: Cathy F.F. LAM

For:

MATERIAL WITH SURFACE NANOMETER FUNCTIONAL

STRUCTURE AND METHOD OF MANUFACTURING THE

SAME

REPLY UNDER 37 C.F.R. § 1.111

Commissioner for Patents P.O. BOX 1450 Alexandria, VA 22313-1450 June 14, 2005

Sir:

In response to the Examiner's Office Action dated February 14, 2005 and in view of the Request for Continued Examination (RCE) being filed concurrently herewith, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application.

This reply includes

Amended Claim set; and

Remarks.